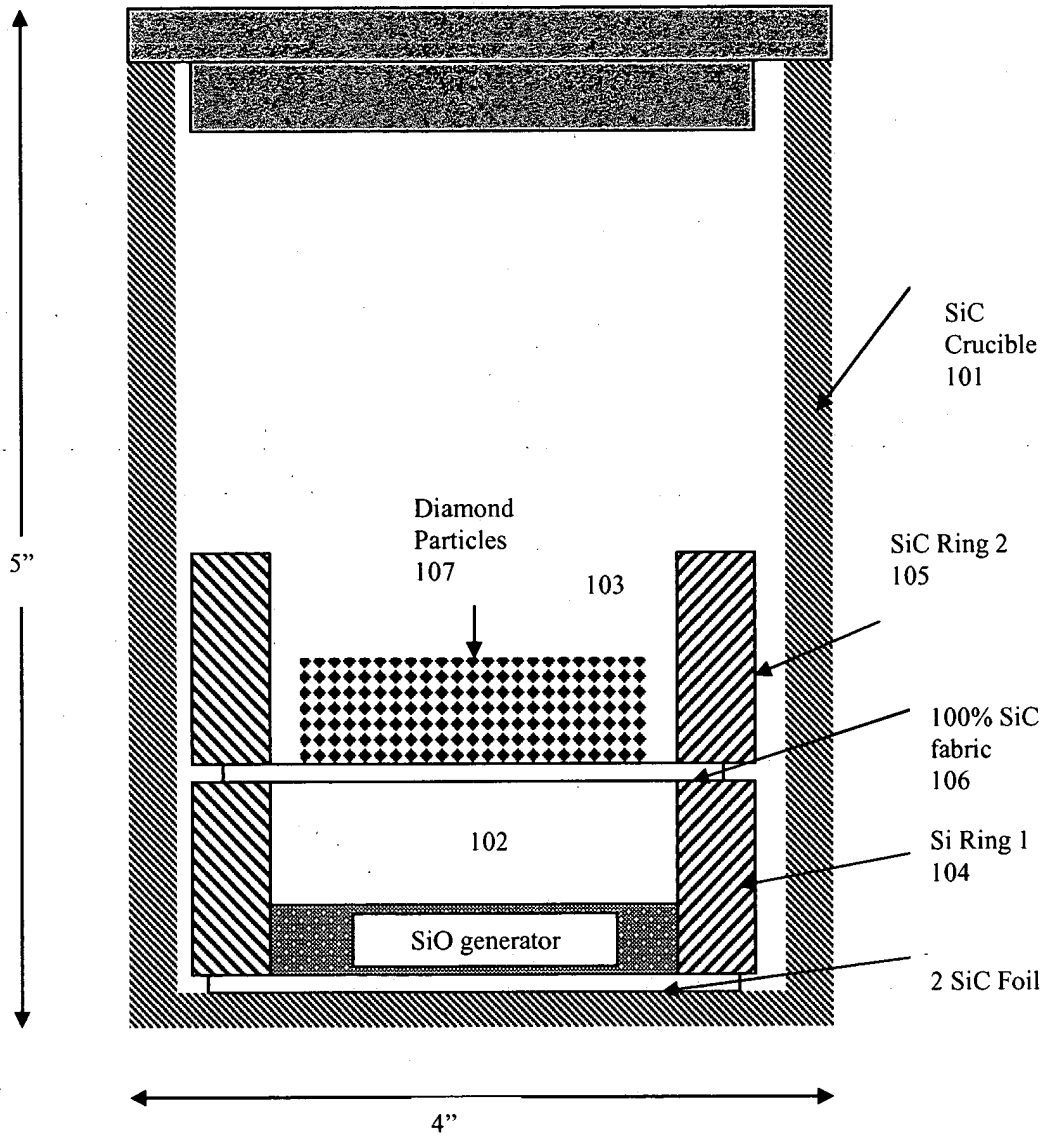
Figure 1. Schematic Of Apparatus For Performing The CVR Process To Coat Diamond Particles With SiC



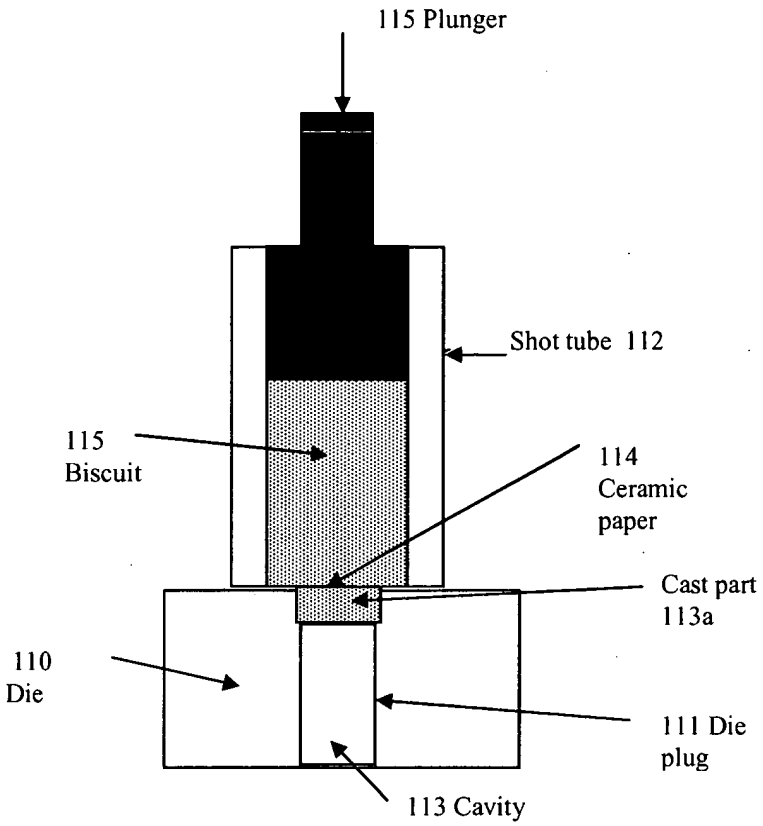


Figure 2- Schematic of the squeeze casting assembly